PROCEEDINGS OF SPIE

High-Power Laser Materials Processing: Lasers, Beam Delivery, Diagnostics, and Applications V

Friedhelm Dorsch Stefan Kaierle Editors

16–18 February 2016 San Francisco, California, United States

Sponsored and Published by SPIE

Volume 9741

Proceedings of SPIE 0277-786X, V. 9741

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

High-Power Laser Materials Processing: Lasers, Beam Delivery, Diagnostics, and Applications V, edited by Friedhelm Dorsch, Stefan Kaierle, Proc. of SPIE Vol. 9741, 974101 © 2016 SPIE · CCC code: 0277-786X/16/\$18 · doi: 10.1117/12.2239343

Proc. of SPIE Vol. 9741 974101-1

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ISSN: 0277-786X ISSN: 1996-756X (electronic) ISBN: 9781628419764

Published by **SPIE** P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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Printed in the United States of America.

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Contents

- v Authors
- vii Conference Committee

SESSION 1 BEAM SHAPING I: JOINT SESSION WITH CONFERENCES 9727 AND 9741

9741 02 Gauss to top-hat beam shaping with aspheres [9741-1]

SESSION 2 BEAM SHAPING II: JOINT SESSION WITH CONFERENCES 9727 AND 9741

- 9741 03 Industrial fiber beam delivery system for ultrafast lasers: applications and recent advances [9741-2]
- 9741 04 Monocrystalline CVD-diamond optics for high-power laser applications [9741-4]
- 9741 05 Computing specific intensity distributions for laser material processing by solving an inverse heat conduction problem [9741-5]

SESSION 3 CUTTING, DRILLING, STRUCTURING

- 9741 06 High precision and high aspect ratio laser drilling: challenges and solutions (Invited Paper) [9741-6]
- 9741 07 Can fiber laser improve high speed multi-pulse drilling of aeronautic alloy? [9741-7]
- 9741 08 Calibration of ultra high speed laser engraving processes by correlating influencing variables including correlative evaluation with SEM and CLSM [9741-8]
- 9741 09 Industrial grade fiber-coupled laser systems delivering ultrashort high-power pulses for micromachining [9741-9]
- 9741 0A The influence of scanning speed and number of scans on the properties of laser formed steel [9741-29]

SESSION 4 JOINING

9741 0B Simulation based analysis of laser beam brazing [9741-10]
9741 0C Laser-based gluing of diamond-tipped saw blades [9741-11]
9741 0D Laser welding of polymers: phenomenological model for a quick and reliable process quality estimation considering beam shape influences [9741-12]

9741 OE	A review article: The mechanical properties and the microstructural behaviour of laser
	metal deposited Ti-6AI-4V and TiC composite [9741-13]

SESSION 5 WELDING

9741 0G	High-power CW and long-pulse lasers in the green wavelength regime for copper welding [9741-15]
9741 OH	Monitoring of solidification crack propagation mechanism in pulsed laser welding of 6082 aluminum [9741-16]
9741 01	Fiber laser welding of dual-phase galvanized sheet steel (DP590): traditional analysis and new quality assessment techniques [9741-17]
9741 OJ	Detection of transient reflections during laser beam welding of copper [9741-18]
9741 OK	Transmission laser bonding of low melting eutectic alloys [9741-30]
SESSION 6	BEAM MEASUREMENT
9741 OL	Measuring laser power as a force: a new paradigm to accurately monitor optical power during laser-based machining operations [9741-19]
9741 OM	Localisation: characterisation of laser beam shape for materials processing using a new parameter [9741-20]
9741 ON	Development of a non-contact diagnostic tool for high power lasers [9741-21]
9741 OP	Absorption driven focus shift [9741-23]
SESSION 7	PROCESS MONITORING
9741 OQ	Comprehensive process monitoring for laser welding process optimization (Invited Paper) [9741-24]
9741 OR	Inline monitoring of laser processing: new industrial results with the low coherence interferometry sensor approach [9741-25]
9741 OS	Observation of melting conditions in selective laser melting of metals (SLM) [9741-26]
9741 OT	Binary hologram based high speed zonal wavefront sensing with reduced estimation time [9741-27]
	POSTER SESSION
9741 OU	Analysis of weld seam uniformity through temperature distribution by spatially resolved detector elements in the wavelength range of 0.3µm to 5µm for the detection of structural changing heating and cooling processes [9741-28]

Authors

Numbers in the index correspond to the last two digits of the six-digit citation identifier (CID) article numbering system used in Proceedings of SPIE. The first four digits reflect the volume number. Base 36 numbering is employed for the last two digits and indicates the order of articles within the volume. Numbers start with 00, 01, 02, 03, 04, 05, 06, 07, 08, 09, 0A, 0B...0Z, followed by 10-1Z, 20-2Z, etc.

Abels, Peter, OS Akin, M., OK Akinlabi, Esther Titilayo, OA, OE Akinlabi, Stephen, 0A Ballach, S., OP Baselt, T., OU Baumann, Esther, Ol Bautze, Thibault, OR Berger, P., 0Q Bohrer, Markus, 08 Boley, M., OQ Boruah, Bosanta R., OT Brand, Helmut, OC Brink, D., 04 Budnicki, Aleksander, 09 Bussière, A., 07 Cromwell, K., 0K Delor, C., 07 Dobler, Michael, OB Dowell, Marla, Ol Dudek, K., OP Dültgen, Peter, OC Eilzer, Sebastian, 03 Erinosho, Mutiu F., OE Fetzer, F., 0Q Fleischhaker, Robert, 09 Freysz, E., 07 Fuchs, U., 02 Funck, Max C., 03 Ganser, Andreas, OJ Gebs, Raphael, 09 Gillner, Arnold, 06 Gotthardt, T., 04 Graf, T., 0Q Guttman, Jeffrey L., ON Hadler, Joshua, OL Harrop, N., OP Hartmann, P., OU He, Chao, 06 Heider, A., 0Q Hennigs, Christian, 0C Hermsdorf, J., OK Hoff, C., 0K Hoffmann, D., 04 Holly, C., 04 Huber, Rudolf, 0G Hustedt, Michael, OC Jarwitz, M., 0Q Kaierle, Stefan, OC, OH, OK

Kaiser, Elke, 0G Kazakov, Andrei, Ol Killi, Alexander, 09, 0G Klausmann, Konrad, OG Kleinbauer, Jochen, 09 Klina, R., 07 Kogel-Hollacher, Markus, OR Kramer, R., OP Lahdo, Rabi, OC Lempe, B., OU Liebl, Stefan, OJ Loosen, Peter, 05 Loumena, C., 07 Maerten, O., OP Maier, H. J., OK Maschke, R., OU McCauley, John, 0N Mielke, Michael, 09 Miller, Stephanie, Ol Möhl, A., 02 Moser, Rüdiger, OR Nebel, C., 04 Nguyen, M., 07 Nirnberger, Robert, 08 Nutsch, Sebastian, 09 Overbuschmann, Johannes, 09 Overmeyer, L., 0H, 0K Pathak, Biswajit, OT Pfeif, Erik, Ol Pricking, Sebastian, 09, 0G Rudek, F., OU Russek, Ulrich A., OD, OM Sanusi, Kazeem Oladele, OA Schmid, Daniel, OB Schmidt, Michael, OB Schmitz, Patrick, OJ Schoenleber, Martin, OR Scholl, Marcus, OD, OM Simmons, Jed A., ON Simonds, Brian, OL Sowards, Jeffrey, OL Sözbir, M. C., 04 Springer, André, 0C Stollenwerk, Jochen, 05 Stolzenburg, Christian, 0G Strebel, Matthias, OR Stritt, P., OQ Stuch, Julia, 0D, 0M Sutter, Dirk H., 09

Suttmann, O., OH Thombansen, U., OS Timpe, Nathalie F., 0D, 0M Traub, M., 04 Uchtmann, Hermann, 06 Vaupel, Matthias, 08 Völl, Annika, 05 von Witzendorff, P., OH Weber, R., 0Q Wedel, Björn, 03 Weinberger, Bernhard, 08 Weller, D., 0Q Welp, Petra, 09 Wenzel, C., 04 Wickenhagen, S., 02 Widmann, C., 04 Wiethop, Philipp, OB Williams, Paul, OL Wloka, Richard, OC Wolf, Martin, 09 Wolf, S., OP Wurz, M. C., 0K Zaeh, Michael F., OJ Zobel, Frank, OC

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